

IN THE U.S. PATENT AND TRADEMARK OFFICE



Applicant: KANG, Tae-Woong

Application No.:

Group:

Filed: August 31, 2001

Examiner:

For: METHOD FOR FORMING CAPACITOR OF SEMICONDUCTOR DEVICE

L E T T E R

Honorable Commissioner of Patents
and Trademarks
Washington, D.C. 20231

August 31, 2001
0630-1187P

Sir:

Under the provisions of 35 USC 119 and 37 CFR 1.55(a), the applicant hereby claims the right of priority based on the following application(s):

<u>Country</u>	<u>Application No.</u>	<u>Filed</u>
REPUBLIC OF KOREA	2000-51214	08/31/00

A certified copy of the above-noted application(s) is(are) attached hereto.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. 1.16 or under 37 C.F.R. 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By: 

GARY D. YACURA
Reg. No. 35,416
P. O. Box 747

Falls Church, Virginia 22040-0747

Attachment
(703) 205-8000
/nv

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I N F O R M A T I O N S H E E T

Applicant: KANG, Tae-Woong

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Priority Claimed Under 35 U.S.C. 119 and/or 120:

COUNTRY	DATE	NUMBER
KOREA	08/31/00	2000-51214

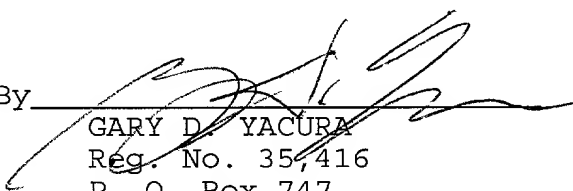
Send Correspondence to: BIRCH, STEWART, KOLASCH & BIRCH, LLP
P. O. Box 747
Falls Church, Virginia 22040-0747
(703) 205-8000

The above information is submitted to advise the USPTO of all relevant facts in connection with the present application. A timely executed Declaration in accordance with 37 CFR 1.64 will follow.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By


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